

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Application No.: 10/724,635



Filed: December 2, 2003

Docket No.: 117926

For: METHOD OF MANUFACTURING OXIDE THIN FILM, METHOD OF
MANUFACTURING FERROELECTRIC THIN FILM, FERROELECTRIC THIN FILM,
FERROELECTRIC MEMORY DEVICE, AND FERROELECTRIC PIEZOELECTRIC
DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. An English-language Abstract of the non-English language reference 1 is attached hereto.
- ☒ 3. A computer-generated English translation of the following Japanese reference(s) has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 1.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

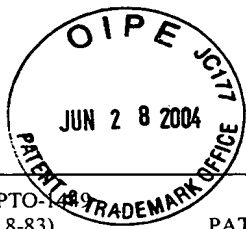
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JAO:TJP/al

Date: June 28, 2004

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Sheet 1 of 1

Form PTO-489 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 117926		APPLICATION NO. 10/724,635	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Takeshi KIJIMA et al.			
				FILING DATE December 2, 2003			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1	JP A 2003-213425 w/Abstract & Translation	07/30/2003	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: June 28, 2004